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Client Reference: OPS-10476

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF
HORI

Confirmation No.: 7533

Group Art Unit: 1743

Appln. No.: 09/867,418

Examiner: Alexander, Lyle

Filed: May 31, 2001

Title: EVALUATION METHOD FOR POLYCRYSTALLINE SILICON

November 5, 2003

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AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Non-Fee Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated September 11, 2003, please amend the above identified application as follows:

IN THE CLAIMS:

1. (Currently amended) An evaluation method for polycrystalline silicon which is used as a material for pulling single crystal silicon, comprising the steps of:

immersing a predetermined amount of the polycrystalline silicon in a predetermined amount of an agent contained in a vessel, which agent is capable of dissolving the polycrystalline silicon; and

~~counting~~ placing a measuring device in the agent having the polycrystalline silicon dissolved therein to count the number of foreign particles dispersed in the agent ~~using a measuring device~~.

2. (Previously presented) An evaluation method for polycrystalline silicon as set forth in claim 1, wherein the measuring device is a particle counter.